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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10033768	FILING DATE 12/26/2001	CLASS 315	SUBCLASS 315.02	GAU 1703	EXAMINER ZELIXON
**APPLICANTS: Tanguay Michael;					
<p>9/6/19/6 Jey</p> <p>**CONTINUING DATA VERIFIED: THIS APPLICATION IS A CIP OF 09/563,784 04/29/2000 Now Pat. 6,508,883 TAF 3/10/3</p>					
** FOREIGN APPLICATIONS VERIFIED:					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO	
Verified and Acknowledged Examiners's initials TAF		534-CIP			
TITLE : System and method of processing composite substrates within a high throughput reactor U.S. DEPT. OF COMM. PAT. & TM. PTO-436 (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
ISSUE FEE		Assistant Examiner	
Amount Due	Date Paid	Total Claims Printed Claims for O.S.	
		DRAWING	
		Sheets Drawn	Figs. Drawn Printed Figs.
		Primary Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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